Supporting Information's

Hierarchical ZnO/Zeolite Nanostructures: Synthesis, Growth Mechanism and Hydrogen Detection

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Nanomaterials hydrogen sensor were largely investigated in the recent times. Some of the recent work is summarized in table 1 [1-11]. However the response of our sensors based on ZnO/Zeolite hierarchical structures is swift and highly promising. Also, Ra. et al studied hydrogen sensing of ZnO nanowires fabricated by top-down approach [12]. The sensor response and recovery time was found to be slow. Navale et al studied hydrogen and liquefied petroleum gas sensor response using ZnO nanostructures [13]. Nevertheless ZnO nanostructures selectivity towards liquefied petroleum gas. Kaciulis et al investigated hydrogen sensing performance of SnO_2 nanowires at high temperature of 530°C. However the response and recovery of hydrogen gas was slow at higher operating temperature [14]. Mubeen et al, studied the palladium (Pd) nanoparticles decorated carbon nanotubes (CNT) for hydrogen gas sensors [15, 16]. The response and recovery time of hydrogen gas was more than 10 min. Jeon et al lately reported the single Pd nanowire based hydrogen gas sensors [17]. The Pd nanowires were fabricated by top-down approach (electron beam lithography). The hydrogen sensors made from single Pd nanowire showed fast response when the thickness of nanowire was kept 20 nm. Contrariwise by modifying the thickness of nanowire the response time and recovery changed. When the nanowires thickness increased to 400 nm the resistance of the sample did not return to the initial value. Also electron beam lithography is costly and time consuming method. We earlier investigated synthesis of In_2O_3 , nanowires, nanoneedles and nanopushpins by vapor transport technique and then studied hydrogen sensing using In2O3 nanostructures devices (9-11). However the devices showed response in from 30-60 seconds. In this work we observed quite *interesting and fast* response (10 s) of hydrogen gas.

Material	diameter	Shape	Response time	Working temperature	Detection limit	Synthesis method	References
TiO ₂	46 nm	Nanotubes	150 (s)	300°C	1000 ppm	Electrochemical deposition	1
SnO ₂	~50 nm	Nanowires	5 min.	200°C	0.5%	Vapor transport	2
ZnO	100-150 nm	Nanorods	20 (s)	350°C	2500 ppm	Chemical approach	3
SnO ₂	200 nm	Nanoholes	2 min.	350°C	1000 ppm	Liquid phase deposition	4
ZnO	10 nm	Nanobelts	100 (s)	50°C	250ppm	Electrochemical deposition	5
TiO ₂	75 nm	Nanosponges	~500 (s)	275°C	4000 ppm	PECVD	6
Al ₂ O ₃	60 nm	Nanowells	~ 60 (s)	RT	500 ppm	Anodization	7
ZnO	500 nm	Microrod	100 (s)	RT	200 ppm	Chemical approach	8
ZnO	70-80 nm	Nanowires	65 (s)	200°C	500 ppm	Microwave evaporation	9
In ₂ O ₃		Nanopushpins	35 (s)	250°C	500 ppm	Vapor transport	10
In ₂ O ₃	70 nm	Nanowires	31 (s)	200°C	500 ppm	Vapor transport	11
ZnO/Zeolite nanocrystals	200 nm	nanospheres	10 (s)	400°C	1000 ppm	Chemical approach	Present Study

Table 1: Summary of hydrogen sensors response built on metal oxide nanostructures



Figure 1: Gas sensor response of ZnO/zeolite nanocrystals for different hydrogen gas concentrations.

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